IN THE UNITED STATES PATENT AND TRADEMARK OFFICE Solication Serial No...... 10/050,334 InventorVishnu K. Agarwal Assignee Micron Technology, Inc. Examiner.....Tuan H. Nguyen Attorney's Docket No...... MI22-1913

Title: Capacitor Fabrication Methods and Capacitor Constructions and Enhanced Surface

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References - See Attached Form PTO-1449

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the United States patents and other references listed on the attached Form PTO-1449. No admission is made regarding whether all the submitted references are prior art.

Citation of these references is respectfully requested.

Respectfully submitted,

Dated: 28 Feb 2007

By:

Reg. No. 44.854

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FORM PTO-1449 U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE PER 2 × 2007 (Use several sheets if necessary)					ATTY. DOCKET NO. MI22-1913 APPLICANT: Vishnu K. Aga			SERIAL NO. 10/050,334	
					FILING DATE January 15, 2002		GR	GROUP 2813	
U.S. PATENT DOCUMENTS									
*Examiner's Initials		Document Number	Date	Name	Name		Subclass Filing Date If Appropriate		
	ΑΑ.	6,583,441	06/2003	Moradi et al.	_				
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OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)									
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.									